

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

J. D. Westwood

Serial No.: (unknown)

Filed: (herewith)

For: METHOD OF MAKING NiFeCo-O-N OR
NiFeCo-N FILMS FOR SHIELDS AND/OR
POLES OF A MAGNETIC HEAD

Group No.: (unknown)

Examiner: (unknown)

Docket No. SJO990037US1



#2

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

INFORMATION DISCLOSURE STATEMENT

Applicant hereby cites the document listed in accompanying Form PTO-1449 with respect to the above-referenced patent application under the provisions of 37 C.F.R., Sections 1.56, 1.97 and 1.98. A copy of the document is attached.

The filing of this Information Disclosure Statement will not be construed to mean that a search was conducted or that no other material information, as defined by 37 C.F.R. 1.56, exists.

The Examiner is respectfully requested to make the listed document of record in connection with the prosecution of the subject application.

Respectfully submitted,

By:

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Date: 8/16/00